

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/766,205	01/28/2004	Shahid Rauf	SC13121TP	3358
23125	7590 03/08/2005		EXAMINER	
	LE SEMICONDUCTO	GOUDREAU, GEORGE A		
	LAW DEPARTMENT 7700 WEST PARMER LANE MD:TX32/PL02			PAPER NUMBER
AUSTIN, T			1763	· · · · -
			DATE MAILED: 03/08/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)
	10/766,205	RAUF ET AL.
Office Action Summary	Examiner	Art Unit
	George A. Goudreau	1763
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the	correspondence address
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be y within the statutory minimum of thirty (30) d vill apply and will expire SIX (6) MONTHS fro c cause the application to become ABANDON	timely filed ays will be considered timely. om the mailing date of this communication. NED (35 U.S.C. § 133).
Status		
 1) Responsive to communication(s) filed on <u>28 Ja</u> 2a) This action is FINAL. 2b) This 3) Since this application is in condition for allowar closed in accordance with the practice under E 	action is non-final. nce except for formal matters, p	
Disposition of Claims		
 4) Claim(s) 1-22 is/are pending in the application. 4a) Of the above claim(s) is/are withdray 5) Claim(s) 1-20, and 22 is/are allowed. 6) Claim(s) 21 is/are rejected. 7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and/or 	wn from consideration.	*
Application Papers		
9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) accomplished any objection to the objection to the objection to the objection drawing sheet(s) including the correct and the objection of the object	epted or b) objected to by the drawing(s) be held in abeyance. S ion is required if the drawing(s) is o	See 37 CFR 1.85(a). Objected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119	•	
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the priority documents application from the International Bureau	s have been received. s have been received in Applica rity documents have been recei u (PCT Rule 17.2(a)).	ation No ved in this National Stage
* See the attached detailed Office action for a list	of the certified copies not recei	GEORGE GOUDREAU PRIMARY EXAMINER
Attachment(s) 1) Notice of References Cited (PTO-892)	4) 🔲 Interview Summa	3-05 (
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail	Date
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date	5) Notice of Informa 6) Other:	I Patent Application (PTO-152)

Application/Control Number: 10/766,205

Art Unit: 1763

1. Claim 1-20, and 22 allowed.

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 3. Claim 21 is rejected under 35 U.S.C. 102(b) as being anticipated by Zeza et. al. (10-2002').

Zeza et. al. disclose a rie etching apparatus, which is inherently capable of performing applicant's claimed etching process. This is discussed on pages 3624-3629. This is shown in figures 1-6. In regards to the examiner's inherency statement, the examiner cites the case law listed below of interest to the applicant in this regard.

In re Swinehart (169 U.S.P.Q. 226 (CCPA)) and In re Best (195 U.S.P.Q. 430 (CCPA) state that when an examiner has reasonable basis for believing that functional characteristics asserted to be critical for establishing novelty in the claimed subject matter may, in fact, be inherent characteristics of the prior art, the examiner possesses the authority to require an applicant to prove that the subject matter shown to be in the prior art does not possess the characteristics relied upon.

In regards to applicant's claimed process limitations in their apparatus claims, the examiner cites the case law listed below of interest to the applicant in this regard.

Application/Control Number: 10/766,205

Art Unit: 1763

Furthermore, it is obvious to one skilled in the art that the configuration of the substrate worked upon by the apparatus claimed in this invention is not patentable in view of In re Young (25 U.S.P.Q. 69, 71 (CCPA 1935)) and In re Rishoi (94 U.S.P.Q. 71,73 (CCPA 1952)). The Court of Customs and Patent Appeals stated in In re Young that inclusion of material worked upon by a machine as element in claim may not lend patentability since claim is not otherwise allowable. Similarly, the Court of Customs and Patent Appeals stated in In re Rishoi that there is no patentable combination between a device and the material upon which it works.

Thus, it is irrelevant that the prior art fails to disclose the specific etching process, which is claimed by the applicant in their apparatus claims since the prior art is inherently capable of conducting applicant's claimed etching process. Further, the etch gasses, and the substrate which are claimed by the applicant are not part of the apparatus. Rather, they are items which the apparatus performs work upon.

4. Claim 21 is rejected under 35 U.S.C. 102(e) as being anticipated by Fuller et. al. (6,703,169).

Fuller et. al. disclose a rie etching apparatus, which is inherently capable of performing applicant's claimed etching process. This is discussed specifically in columns 17-18; and discussed in general in columns 1-22. This is shown in figures 4-12. In regards to the examiner's inherency statement, the examiner cites the case law listed below of interest to the applicant in this regard.

In re Swinehart (169 U.S.P.Q. 226 (CCPA)) and In re Best (195 U.S.P.Q. 430 (CCPA) state that when an examiner has reasonable basis for believing that functional characteristics asserted to be critical for establishing novelty in the claimed subject matter may, in fact, be inherent characteristics of the prior art, the examiner possesses the authority to require an applicant to prove that the subject matter shown to be in the prior art does not possess the characteristics relied upon.

In regards to applicant's claimed process limitations in their apparatus claims, the examiner cites the case law listed below of interest to the applicant in this regard.

Application/Control Number: 10/766,205

Art Unit: 1763

Furthermore, it is obvious to one skilled in the art that the configuration of the substrate worked upon by the apparatus claimed in this invention is not patentable in view of In re Young (25 U.S.P.Q. 69, 71 (CCPA 1935)) and In re Rishoi (94 U.S.P.Q. 71,73 (CCPA 1952)). The Court of Customs and Patent Appeals stated in In re Young that inclusion of material worked upon by a machine as element in claim may not lend patentability since claim is not otherwise allowable. Similarly, the Court of Customs and Patent Appeals stated in In re Rishoi that there is no patentable combination between a device and the material upon which it works.

Thus, it is irrelevant that the prior art fails to disclose the specific etching process, which is claimed by the applicant in their apparatus claims since the prior art is inherently capable of conducting applicant's claimed etching process. Further, the etch gasses, and the substrate which are claimed by the applicant are not part of the apparatus. Rather, they are items which the apparatus performs work upon.

- 5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.
- 6. Any inquiry concerning this communication should be directed to examiner George A. Goudreau at telephone number (571)-272-1434.

George A. Goudreau Primary Examiner

Art Unit 1763